



CERTIFICATE OF MAILING

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5/24/05
Date

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Serial No.: 10/814,713
Filed: March 31, 2004
Group Art Unit: 1762
Examiner: David P. Turocy
Applicant: Raymond Joe, John Gumpher, Anthony Dip
Title: **A METHOD FOR EXTENDING TIME BETWEEN CHAMBER
CLEANING PROCESSES**
Attorney Docket: TPS-012
Confirmation No.: 8772

Cincinnati, Ohio 45202

May 24, 2005

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

In accordance with the duty of candor and good faith imposed by 37 C.F.R. §1.56, and means of complying therewith according to 37 C.F.R. §§1.97 and 1.98, the references listed on the attached Form PTO-1449 are called to the attention of the United States Patent and Trademark Office in connection with the above-identified patent application. Because the requirement (37 C.F.R. §1.98(a)(2)(i)) for submitting copies of U.S. patents and published applications has been

waived, copies of only the foreign cited references and/or other documents are enclosed herewith.

Applicants have also enclosed a copy of the foreign Search Report listing these references.

It is submitted that the cited references do not disclose or render obvious the subject matter claimed in the present application.

Certifications under 37 C.F.R. § 1.97(e) and § 1.704(d)

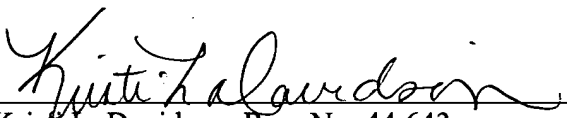
Each item of information contained in the information disclosure statement was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of the information disclosure statement.

Each item of information contained in the information disclosure statement was cited in a communication from a foreign patent office in a counterpart application and to the knowledge of the person signing the certification after making reasonable inquiry, no item of information contained in the information disclosure statement was known to any individual designated in 37 C.F.R. § 1.56(c) more than thirty days prior to the filing of the information disclosure statement.

Applicants do not believe that any fees are due in connection with this submission. However, if such petition is due or any fees are necessary, the Commissioner may consider this to be a request for such and charge any necessary fees to Deposit Account No. 23-3000.

Respectfully submitted,

WOOD, HERRON & EVANS, L.L.P.

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K:\TPS\012\Supp IDS from Search Rpt.wpd

SUBSTITUTE FORM PTO-1449 (MODIFIED)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. TPS-012		SERIAL NO. 10/814,713							
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use several sheets if necessary)				APPLICANT Raymond Joe et al.		FILING DATE March 31, 2004							
				GROUP 1762									
				U.S. PATENT DOCUMENTS									
EXAMINER INITIAL		PATENT NUMBER						ISSUE DATE	PATENTEE	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
	A.A	6	4	1	3	3	2	1	07/02/2002	Kim et al.	118	725	12/07/2000
	A.B												
	A.C												
	A.D												
	A.E												
	A.F												
	A.G												
	A.H												
	A.I												
	A.J												
	A.K												
FOREIGN PATENTS OR PUBLISHED FOREIGN PATENT APPLICATIONS													
		DOCUMENT NUMBER			PUBLICATION DATE			COUNTRY OR PATENT OFFICE		CLASS	SUBCLASS	TRANSLATION (YES/NO)	
	A.L	2003051452			02/21/2003			EP		H01L	21/205	Abstract Only	
	A.M	2003051533			02/21/2003			EP		H01L	21/68	Abstract Only	
	A.N	2003100743			04/04/2003			EP		H01L	21/318	Abstract Only	
	A.O												
	A.P												
	A.Q												
OTHER DOCUMENTS (Including Author, Title, Date, Place of Publication)													
	A.R	Bolscher et al., <u>Pre-Treatment of Reactor Parts for Chemical Vapor Deposition Reactors</u> , US 2002/0058108 A1; publication date 05/16/2002; filed 11/07/2001; U.S. Class 427/299											
	A.S	Rossman, <u>Si Seasoning to Reduce Particles, Extend Clean Frequency, Block Mobile Ions and Increase Chamber Throughput</u> , US 2003/0211735 A1; publication date 11/13/2005; filed 06/16/2003; U.S. Class 438/680											
	A.T												
EXAMINER									DATE CONSIDERED				
EXAMINER: Initial if citation considered, whether or not in conformance. Draw line through citation only if not in conformance <u>and</u> not considered. Include a copy of this form with next communication to Applicant.													